

AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 2815
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q85660

Heiji WATANABE, et al.

Appln. No.: 10/521,311

Group Art Unit: 2815

Confirmation No.: 1690

Examiner: WARREN, MATTHEW E

Filed: January 14, 2005

For: SEMICONDUCTOR DEVICE, AND MANUFACTURING METHOD AND
MANUFACTURING APPARATUS OF THE SAME

RESPONSE UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

CONSIDERED: /MW/ (07/24/2009)

Sir:

In response to the Office Action dated April 15, 2009, please consider the remarks as
follows on the accompanying pages.

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